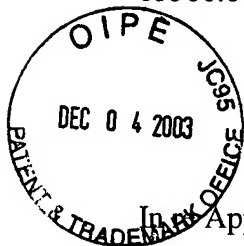


03500.013314.2

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of:

TOSHIKAZU ONISHI ET AL.

Application No.: 10/014,131

Filed: December 13, 2001

For: METHOD FOR MANUFACTURING )  
ELECTRON EMISSION ELEMENT, :  
ELECTRON SOURCE, AND IMAGE )  
FORMING APPARATUS :

Examiner: K. Ramsey

Group Art Unit: 2879

December 1, 2003

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Preliminary to continued examination, please amend the above-identified application as follows, the claims changes being reflected in the listing that begins at page 2, and the Remarks beginning at page 6.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

December 1, 2003.

(Date of Deposit)

LEONARD P. DIANA (Reg No. 29,296)

(Name of Attorney for Applicants)

A handwritten signature in cursive script, appearing to read "Leonard P. Diana".

Signature

December 1, 2003

Date of Signature